

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re of Applicant)
Migaku Takahashi) Art Group: 1753
Serial No.:)
Filing Date: September 18, 2003)
Title: MAGNETIC THIN FILM AND) Examiner: CANTELMO, GREGG
PRODUCTION METHOD THEREFOR)
)
)

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner of Patents and Trademarks
Box: Patent Application
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. § 1.56, Applicant wishes to bring to the attention of the Examiner the documents identified on the attached form PTO-1449. Applicant respectfully requests that these documents be made of record in the present application.

A copy of each of the documents is enclosed.

It is respectfully requested that the Examiner indicate consideration of the cited references by returning a copy of the attached form PTO-1449 with initials or other appropriate marks.

Respectfully submitted,



Randall J. Knuth
Registration No. 34,644

RJK/mdc

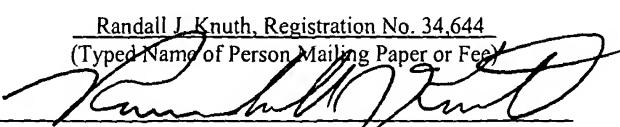
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Enc. Form PTO-1449
Cited Art References
Return postcard

Randall J. Knuth, Registration No. 34,644
(Typed Name of Person Mailing Paper or Fee)



(Signature of Person Mailing Paper or Fee)

INFORMATION DISCLOSURE STATEMENT		Page <u>1</u> Of <u>1</u>					
		Atty. Docket No. FUK-12CPA		Serial No.			
		Applicant Migaku Takahashi					
		Filing Date September 18, 2003		Group 1753			
U.S. PATENT DOCUMENTS							
Examiner Initial *		Document No.	Date	Name	Class	Subclass	Filing Date
	AA	5,736,264	7/98	Ishiwata et al.	G11B	5/66	3/93
	AB	5,382,305	1/95	Terunuma et al.	H01F	10/00	8/93
	AC	5,173,370	12/92	Takahashi et al.	G11B	5/00	8/90
	AD	5,465,475	11/95	Kinoshita et al.	G11B	5/42	7/93
	AE	5,401,609	3/95	Haratani et al.	G11B	1/24	6/94
	AF	5,334,433	8/94	Tominaga	B32B	3/00	12/92
	AG	5,154,983	10/92	Watanabe	C22C	38/00	10/90
	AH	6,027,825	02/00	Shiratori et al	G11B	05/66	06/97
	AI	5,750,209	05/98	Samoto	H05H	01/24	09/96
	AJ	5,667,862	09/97	Nakane et al	G11B	05/66	04/91
	AK	5,659,537	08/97	Hirokane et al	G11B	07/00	06/95
	AL	5,687,045	11/97	Okai et al	G11B	05/31	11/95
FOREIGN PATENT DOCUMENTS							
		Document No.	Date	Country	Class	Subclass	Translation
							Yes
	AM	59-45911	3/84	Japan	C01B	21/06	3/82
	AN	62-164868	7/87	Japan	C23C	14/06	1/86
	AO	2-212320	8/90	Japan	C01G	49/00	2/89
	AP	61-148809	7/86	Japan	H01F	41/18	12/84
	AQ	62-285406	12/87	Japan	H01F	10/10	6/86
	AR	2-109309	4/90	Japan	H01F	10/14	10/88
	AS	60-25211	2/85	Japan	H01F	41/18	7/83
OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)							
	AT	<u>Journal of Applied Physics</u> 53 (11), November 1982. Pp. 8332-8334. "Metastable Fe Nitrides with High Bs Prepared by Reactive Sputtering". A. KANO, N.S. KAZAMA, H. FUJIMORI					
EXAMINER:			DATE CONSIDERED:				
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							